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## Non-inductive Plasma Start-up and Current Ramp-up in NSTX-U

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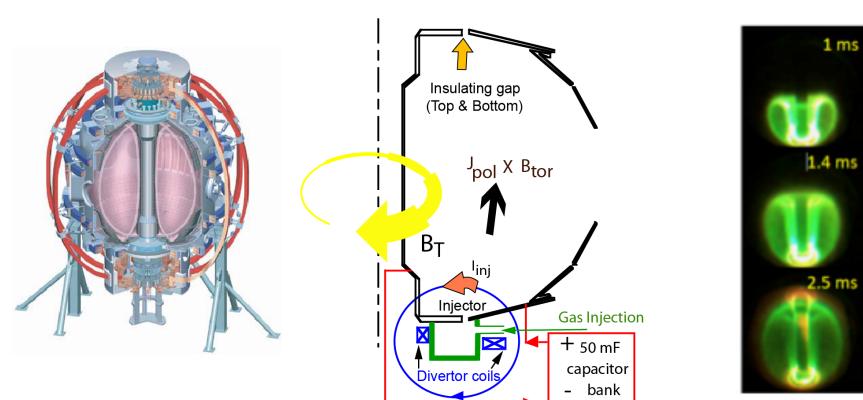
and the NSTX Research Team

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## NSTX-U Will Use Transient CHI For Solenoid-free Plasma Start-up With Subsequent Current Ramp-up Using NBI



- Parameters to consider
  - Current multiplication factor
  - Effect of toroidal field
  - Magnitude of generated plasma current
  - New desirable features?

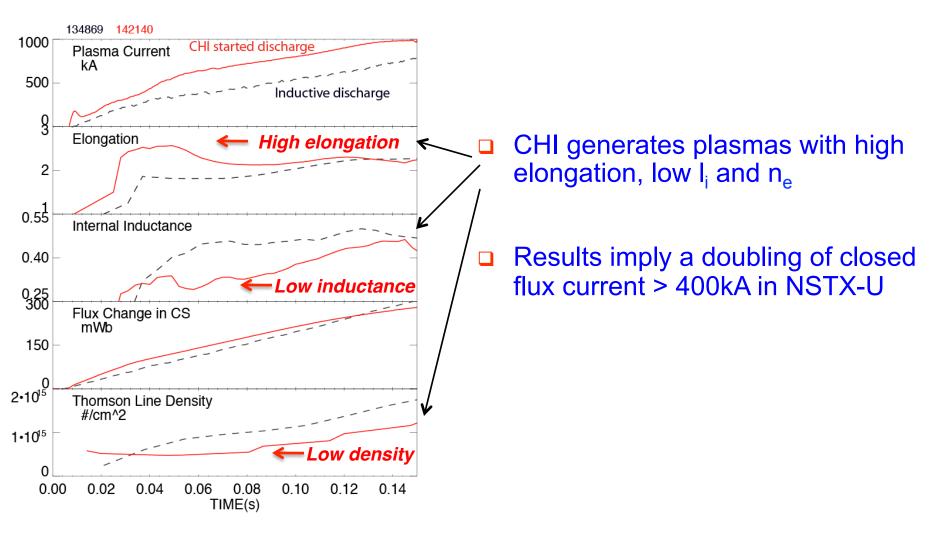
Fast camera: F. Scotti, L. Roquemore, R. Maqueda

CHI for an ST: T.R. Jarboe, Fusion Technology, 15 (1989) 7 Transient CHI: R. Raman, T.R. Jarboe, B.A. Nelson, et al., PRL 90, (2003) 075005-1

**NSTX** 

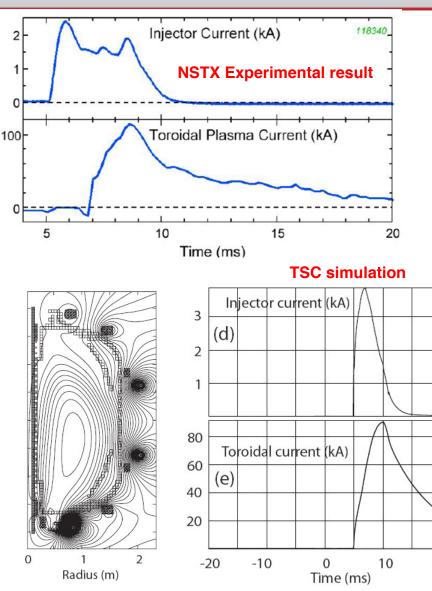
# Plasma discharge ramping to 1MA requires 35% less inductive flux when coaxial helicity injection (CHI) is used

#### CHI assisted startup in NSTX





# TSC Simulations are being used to Understand CHI-Scaling with Machine Size



- Time-dependent, free-boundary, predictive equilibrium and transport
- Solves MHD/Maxwell's equations coupled to transport and Ohm's law
- Requires as input:
  - Device hardware geometry
  - Coil electrical characteristics
  - Assumptions concerning discharge characteristics
- Models evolutions of free-boundary axisymmetric toroidal plasma on the resistive and energy confinement time scales.
- NSTX vacuum vessel modeled as a metallic structure with poloidal breaks
  - An electric potential is applied across the break to generate the desired injector current

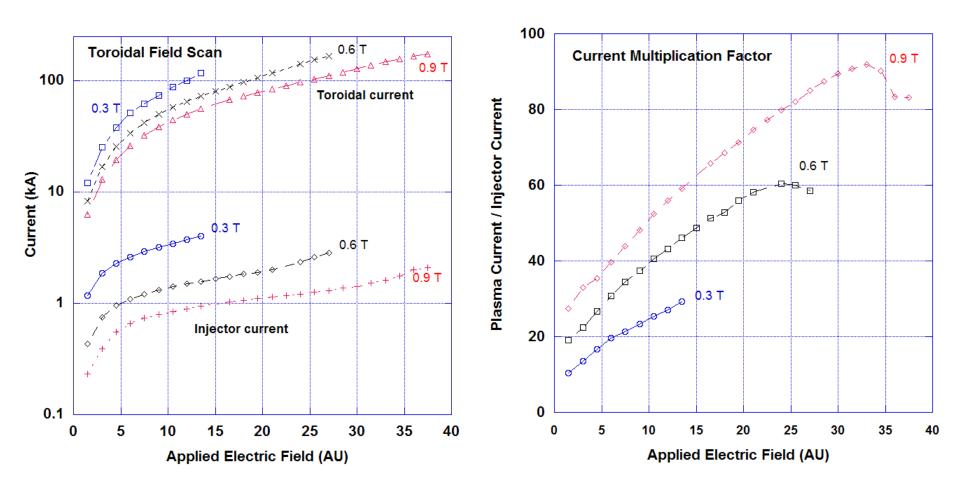
Early phase of CHI start-up now being studied using NIMROD simulations

(E. B. Hooper, poster Thursday PP8.00025)

TSC: Developed by S.C. Jardin (PPPL)

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## TSC Simulations Show Increasing Current Multiplication as TF is Increased



- Observed current multiplication factors similar to observations in NSTX
  - Higher toroidal field important as it reduces injector current requirement

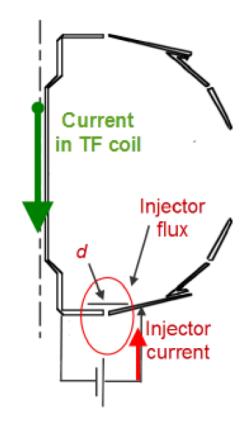
R. Raman, S.C. Jardin, J. Menard, T.R. Jarboe et al., Nuclear Fusion 51, 113018 (2011)

## Externally Produced Toroidal Field makes CHI much more Efficient in a Lower Aspect Ratio Tokamak

• Bubble burst current\*:  $I_{inj} = 2\psi_{inj}^2 / (\mu_o^2 d^2 I_{TF})$ 

 $\psi_{inj}$  = injector flux d = flux foot print width  $I_{TF}$  = current in TF coil

- Current multiplication increases with toroidal field
  - Favorable scaling with machine size
  - Increases efficiency (10 Amps/Joule in NSTX)
  - Smaller injector current to minimize electrode interaction

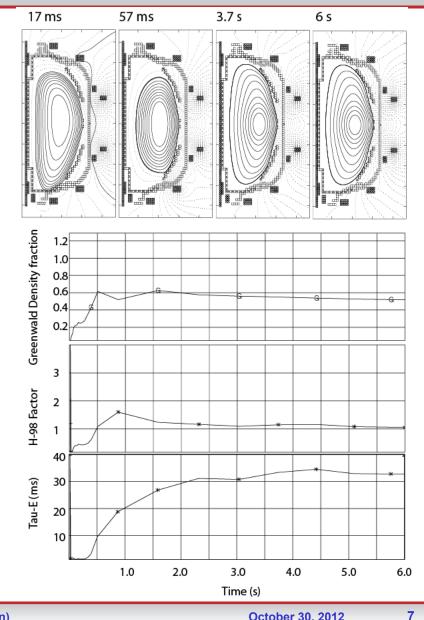




<sup>\*</sup> T.R. Jarboe, Fusion Tech. 15, 7 (1989)

## Preliminary Scenario for Ramping to 1MA in NSTX-U

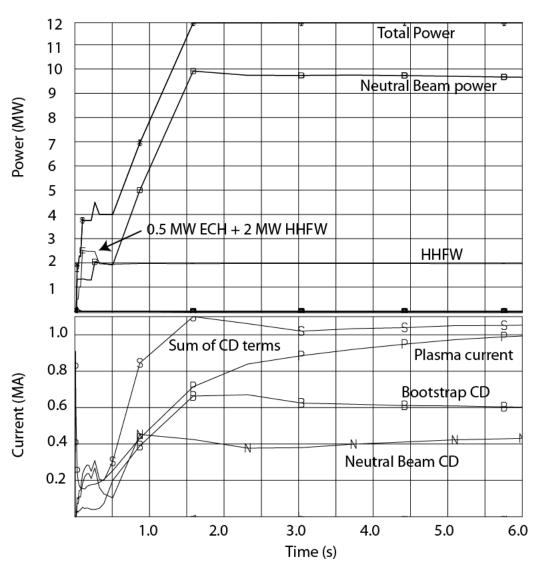
- Initial 400 kA CHI target is generated by TSC
  - CHI phase ends at 17ms
  - Horizontal and vertical position control of CHI-started discharge initiated at 20 and 30ms
  - Density of 0.6 n<sub>GW</sub> maintained during current ramp-up
  - H98 factor maintained near 1
  - $\tau_{\rm F}$  maintained at about 30ms, consistent with NSTX experimental results
  - Normalized internal inductance (not shown)maintained below 0.6 during current ramp





## NSTX-U Heating and Current Drive Actuators are Adequate for Current Ramp-up to 1 MA

- 0.5 MW ECH (absorbed power) maintained until 0.3s
  to heat CHI plasma
- 2 MW HHFW retained until 6s
- NBI power programmed to increase with I<sub>p</sub> and density
- Power ramp-up adjusted to avoid generation of very hollow current profiles
- H-mode initiated at 500ms
- T<sub>e</sub> of 1.7 keV is maintained until 6s
- Bootstrap & NBI current overdrive increases I<sub>p</sub> to 1 MA at 6s





#### NSTX-U will Develop Full Non-inductive Start-up and Current Ramp-up in support of FNSF and next step Tokamaks

- 0.3MA current generation in NSTX validates capability of CHI for high current generation in a ST (>400 kA projected for NSTX-U)
- Successful coupling of CHI started discharges to inductive ramp-up & transition to an H-mode demonstrates compatibility with high-performance plasma operation
- CHI start-up has produced the type of plasmas required for non-inductive ramp-up and sustainment (low internal inductance, low density)
- Favorable scaling with increasing machine size (from two machines of vastly different size, HIT-II and NSTX and in TSC simulations)
- Initial full discharge simulations (CHI start-up + NBI CD) using TSC provides viable scenarios for current ramp-up to 1MA
- NSTX-U is well equipped with new capabilities to study full non-inductive start-up and current ramp-up

- 2x Higher TF, 1MW ECH, Second Tangential NBI for CD, 2x higher CHI voltage, >2.5x more injector flux, Improved upper divertor coils



#### **Back-up Slides**

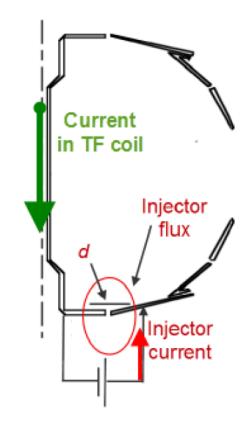


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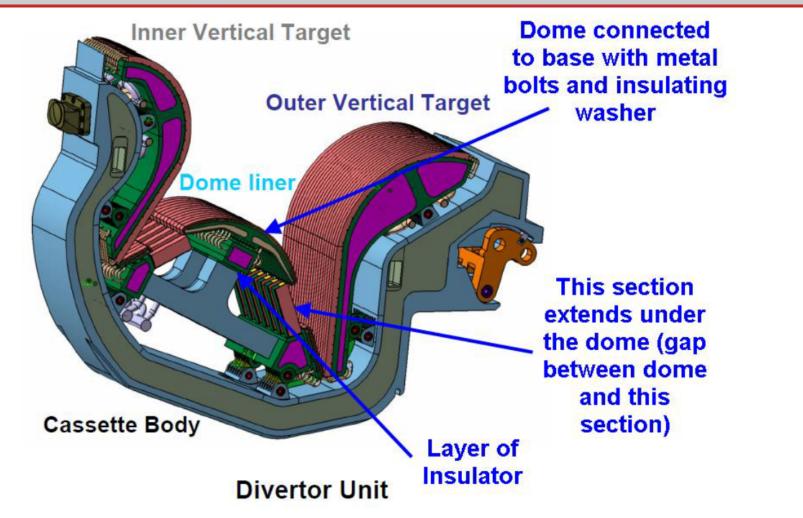
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<sup>\*</sup> T.R. Jarboe, Fusion Tech. 15, 7 (1989)

#### **Example of CHI Insulator Installation in a Reactor** (In ITER, the Dome Region would be Insulated from the Vessel)



#### Insulator is under compression and shielded from neutron

(Concept is similar to the biased ring electrode on DIII-D, but because of the short pulse length, and because of the lack of a pre-existing plasma, the requirements on the insulator are considerably less demanding than on DIII-D)

**(III)** NSTX

#### **Requirements for the CHI Insulator are Less Demanding than the Insulation Requirements for a Mineral Insulated Solenoid**

- Insulator Resistance > 10hm
- Resistance to be maintained only during the plasma start-up phase (<30 ms in duration)</li>
- The actual high-voltage phase < plasma start-up phase
- During the plasma start-up phase, there is no pre-existing plasma that can short out the insulator (CHI current path is controlled by pre-programmed vacuum field line pattern)
- After the high-voltage phase, insulator could be shorted-out, if necessary



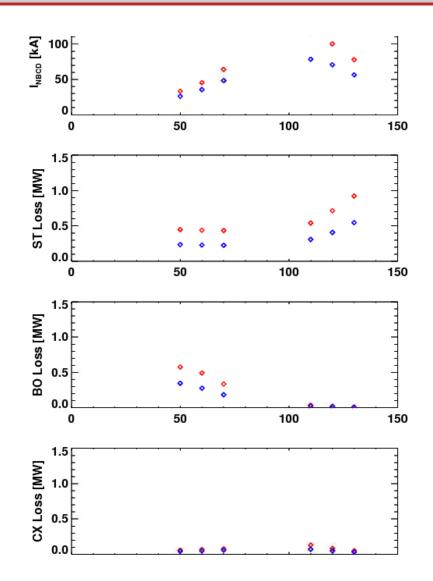
# Because the Insulator Resistance is very low (few times the plasma impedance) other possibilities exist

- Layers of thin resistive metal coated with insulating layers
- Powdered, weakly bonded, insulator sandwiched between two metal plates
- The HIT-Si device used an insulator spray to achieve insulation *in a plasma environment* in an more complicated vessel geometry
- .... Other possibilities (including conventional insulator technology currently planned for next step machines to insulate PF coils and other components)



## Stefan TRANSP Calculations (300kA, 2MW NBI single source, Blue: 65kV, Red 80kV)

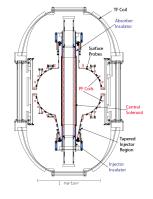
shot	Beam	Voltage	runID
140353	<b>50</b>	80	N10
140353	60	80	N11
140353	70	80	N12
140353	110	80	N13
140353	120	80	N14
140353	130	80	N15
140353	<b>50</b>	<b>65</b>	N20
140353	60	<b>65</b>	N21
140353	70	<b>65</b>	N22
140353	110	<b>65</b>	N23
140353	120	<b>65</b>	N24
140353	130	<b>65</b>	N25



These runs have the NUBEAM output for a single (slightly reversed) q-profile, Greenwald fraction, confinement level,...

Thomson line density is 1 – 1.5E15 /cm<sup>2</sup> = 1-1.5E13 /cm<sup>3</sup> About twice that for a CHI discharge

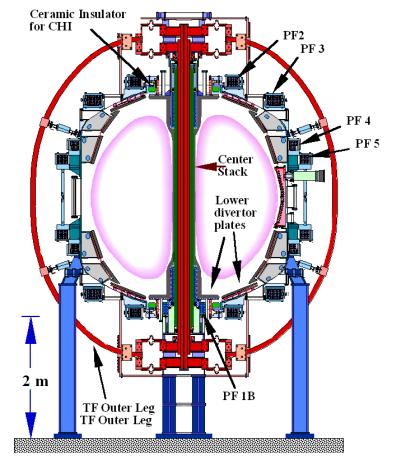
#### **NSTX CHI Research Follows Concept Developed in HIT-II**



#### **Concept exploration device HIT-II**

- Built for developing CHI
- Many close fitting fast acting PF coils
- 4kV CHI capacitor bank

## NSTX plasma is ~30 x plasma volume of HIT-II

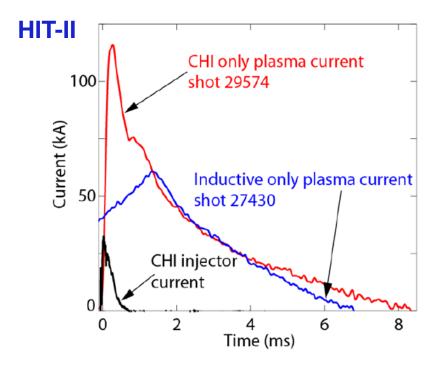


#### **Proof-of-Principle NSTX device**

- Built with conventional tokamak components
- Few PF coils
- 1.7kV CHI capacitor bank

#### **()** NSTX

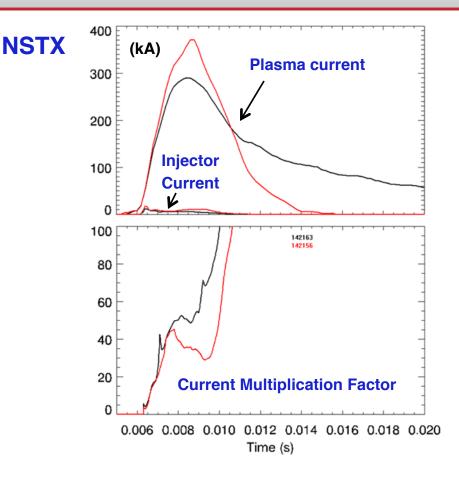
#### Very High Current Multiplication (Over 70 in NSTX) Aided by Higher Toroidal Flux



#### -30kA of injector current generates 120kA of plasma current

-Best current multiplication factor is 6-7

## -Current multiplication factor in NSTX is 10 times greater than that in HIT-II

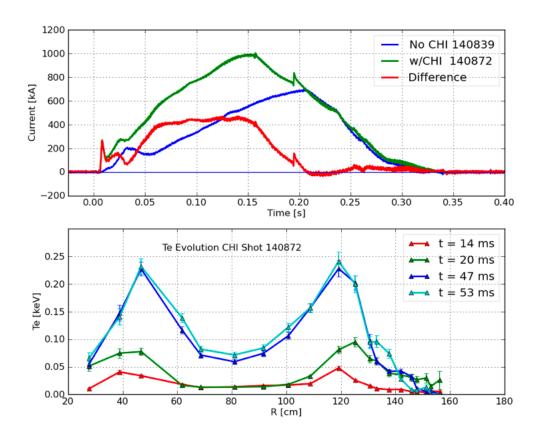


## - Over 200kA of current persists after CHI is turned off

R. Raman, B.A. Nelson, D. Mueller, et al., PRL 97, (2006) 17002



# Using Only 27kJ of Capacitor Bank Energy CHI Started a 300kA Discharge that Coupled to Induction



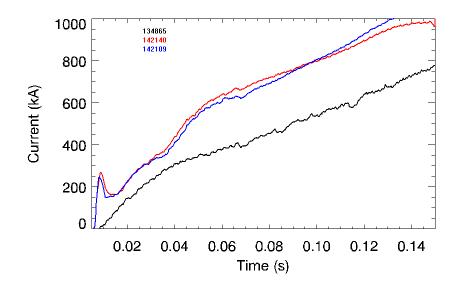
• Ramped up to 1MA after startup, using 0.3Wb change in solenoid flux

 Hollow electron temperature profile maintained during current ramp

> - Important beneficial aspect of using CHI startup

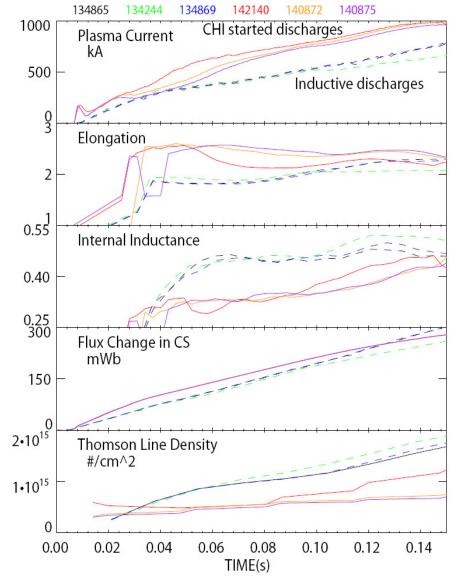
#### $\cdot$ Discharges with early high T\_e ramp-up to higher current

## NSTX has made Considerable Progress in Developing CHI as a Method to Start-up an ST

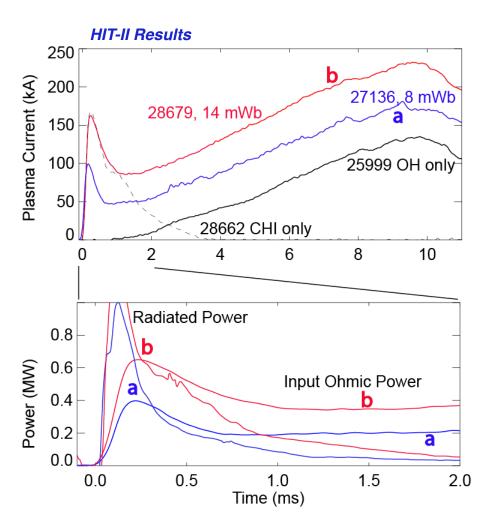


- Best inductive plasma (from 10 YR NSTX data base) uses 340 mWb of solenoid flux to get to 1MA
- Un-optimized CHI started discharges require 258 mWb
- Full non-inductive start-up and ramp-up will be developed on NSTX-U

•R. Raman, et al., Phys Plasmas, 18, 092504 (2011)



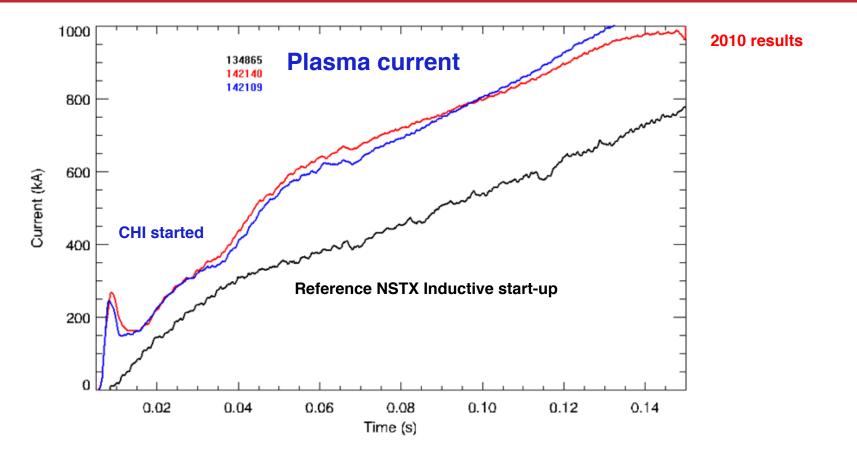
#### Inductively Coupled Current Ramps-up After Input Power Exceeds Radiated Power



R. Raman, T.R. Jarboe, R.G. O'Neill, et al., NF 45 (2005) L15-L19 R. Raman, T.R. Jarboe, W.T. Hamp, et al., PoP 14 (2007) 022504

- Identical loop voltage programming for all cases
- Coupling current increases as injector flux is increased
- Radiated power can be decreased by using W or Mo target plates
  - Start-up plasma (inductive or CHI) is cold (few 10s of eV)
    - Reduce Low-z line radiation
  - Auxiliary heating would ease requirements on current rampup system

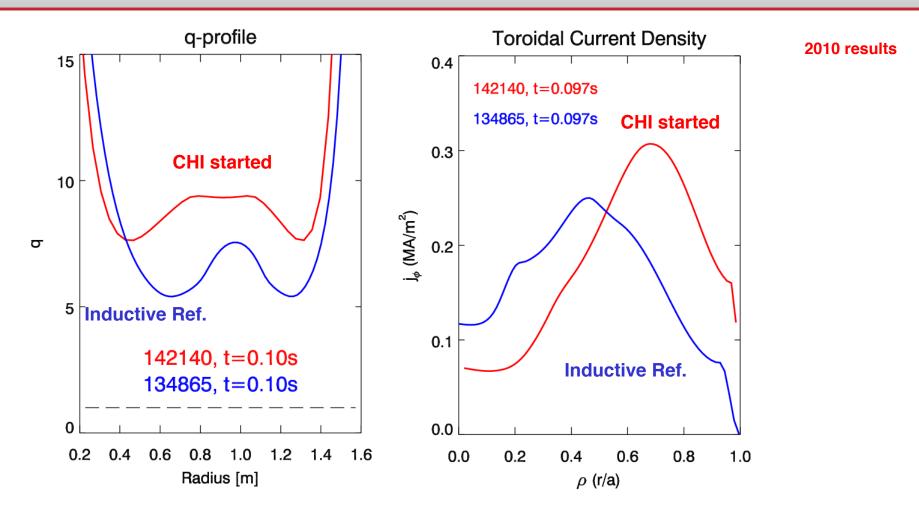
#### Standard L-mode NSTX Discharge Ramps to 1MA Using 50% More Inductive Flux than a CHI Started Discharge



Reference Inductive discharge:Uses 396mWb to get to 1MACHI started discharge:Uses 258 mWb to get to 1MA (53% less flux)NSTX inductive start-up:138mWb flux typically generates 400kA of plasma currentBest CHI-startup discharges:138mWb flux generated 650kA

**()** NSTX

## CHI Start-up Discharges Show Plasma Current Driven at Large Radius



These are the type of plasmas needed for advanced scenario operations

MSE & LRDFIT: H. Yuh, J. Menard, S. Gerhardt

